
Basics of femtosecond laser spectroscopy

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What's so Special About Femtosecond Lasers???

- Short optical pulse.
 - Most of energy dissipation and transfer processes occur on the time scale larger than 100 fs.
 - Femtosecond laser pulses enable one to excite the species studied “instantly” ($t_{exc} \ll t_{rel}$)
 - Dynamics of the excited state can be monitored with high temporal resolution ($\sim 0.5 \tau_{pulse} \approx 12\text{-}50$ fs for most of commercial lasers)
 - *Visualization of ultrafast dynamical processes (fluorescence, excited state absorption)*
- High peak power of the light
 - $I \sim J/\tau_{pulse}$, I – Power, J – pulse energy.
 - 1 mJ pulse with 10 ns duration - **0.1 MW**
 - 1 mJ pulse with 100 fs duration - **10 GW**
 - *Non-linear spectroscopy and materials processing (e.g., multi-photon absorption, optical harmonics generation, materials ablation, etc.)*

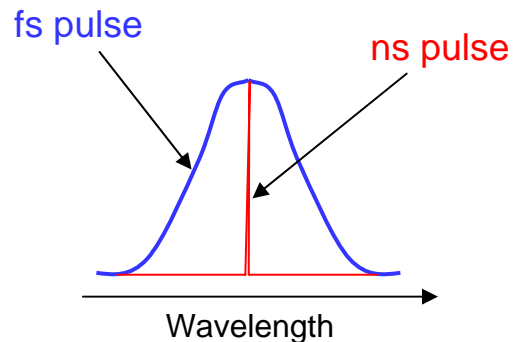
W. Kaiser, ed., “*Ultrashort Laser Pulses: Generation and Applications*”, Springer-Verlag, Berlin, **1993**

How to Prepare a Femtosecond Pulse I

Femtosecond laser pulses are usually Fourier transform-limited pulses

$\Delta\omega \cdot \Delta t \approx 2\pi$ \longrightarrow $\Delta\omega \approx 2\pi/\Delta t$ \longrightarrow Large spectral bandwidth for short pulses

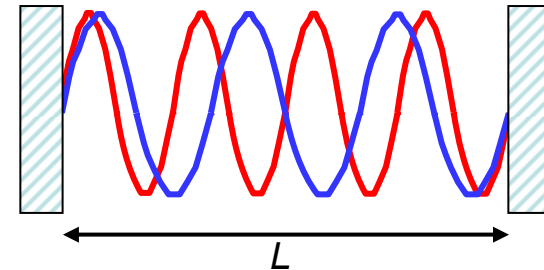
$$\Delta\lambda \approx \lambda^2 / (c\Delta t) \quad \Delta\lambda \approx 21 \text{ nm for } 100 \text{ fs pulses with } \lambda_0 = 800 \text{ nm}$$



Large bandwidth limits the choice of the laser active medium (broad-band materials only, e.g., Ti:Sapphire, laser dyes) and laser cavity design (no bandwidth limiting elements, such as narrowband mirrors)

How to Prepare a Femtosecond Pulse II

Laser mode – combination of frequency (ω) and direction (\mathbf{k}) of the electromagnetic wave allowed by the laser cavity geometry.

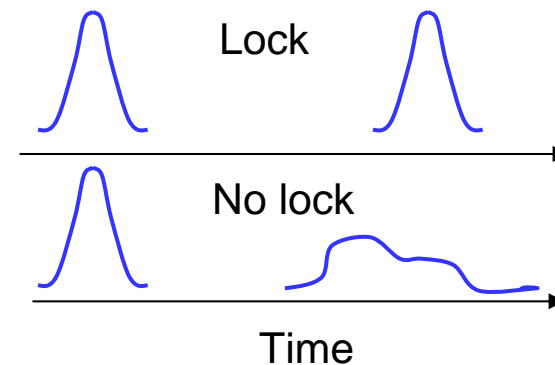


The spectrum of laser modes is not continuous $\lambda_n = 2L/n$

$$I(t) = \sum_{n=0}^N A_n \sin(\omega_n t + \varphi_n)$$

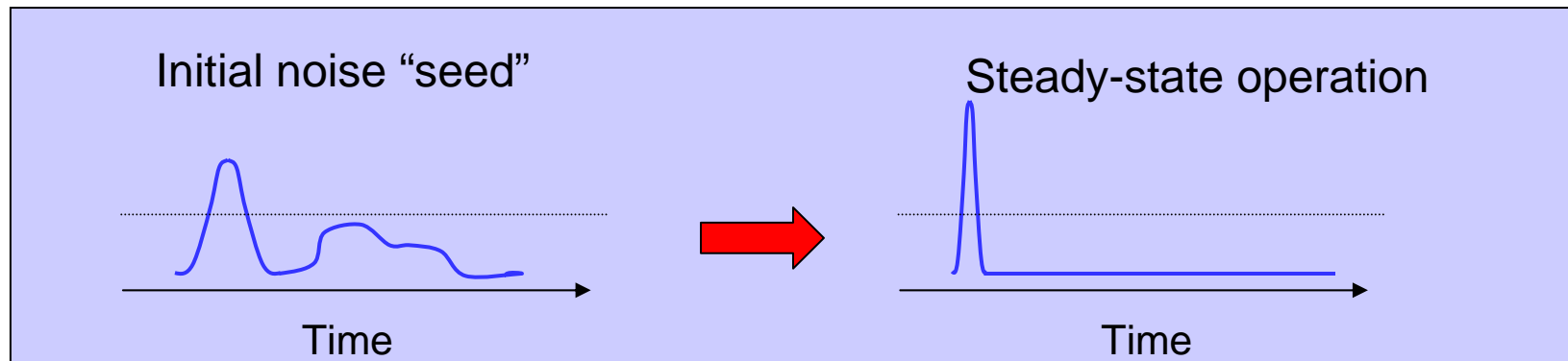
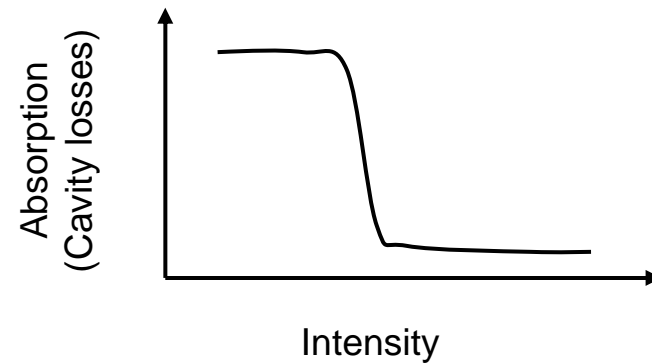
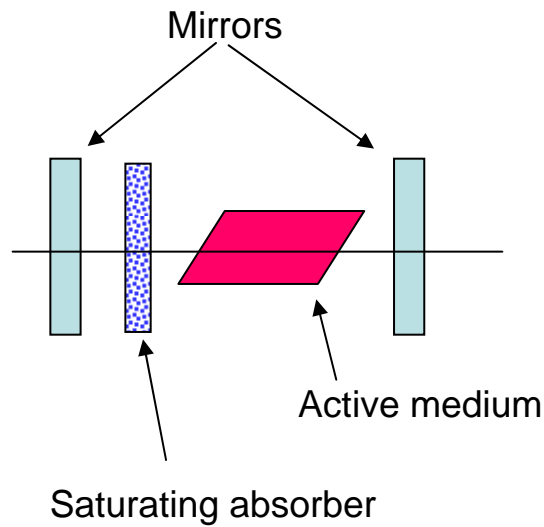
Laser pulse as a sum of modes

Relative phase of the modes has to be constant (locked) in order to obtain a stable output pulse



Passive Mode-Locking

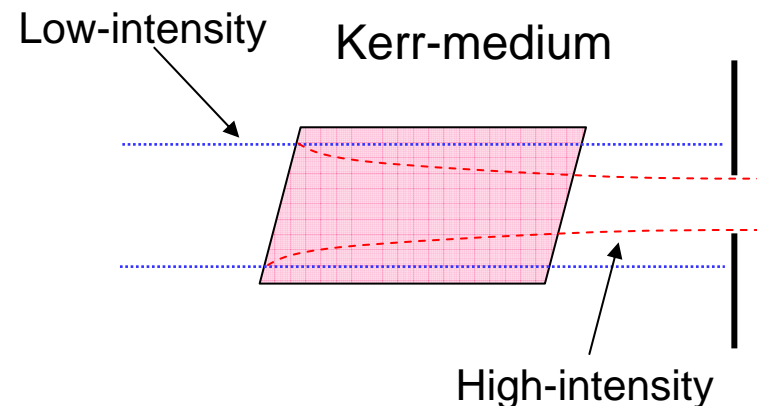
Saturating absorber technique



Passive Mode-Locking II

Kerr-lens mode-locking

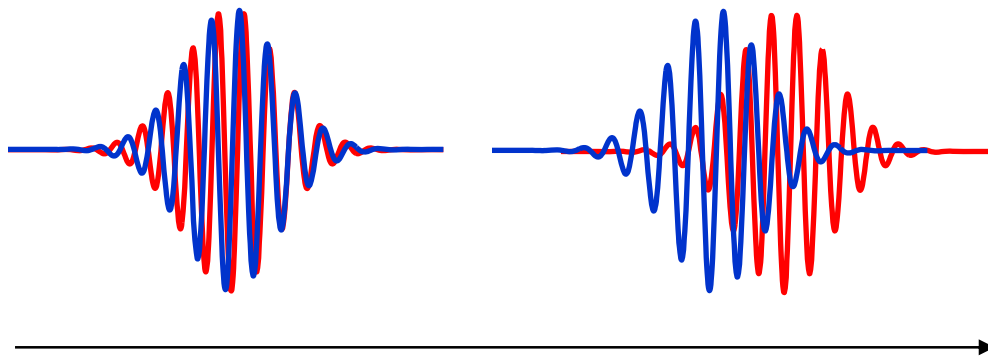
- Kerr's effect – intensity-dependent index of refraction: $n = n_0 + n_2 I$
- The e/m field inside the laser cavity has Gaussian distribution of intensity which creates similar distribution of the refractive index.
- High-intensity beam is self-focused by the photoinduced lens.



- High-intensity modes have smaller cross-section and are less lossy. Thus, Kerr-lens is similar to saturating absorber!
- Some lasing materials (e.g. Ti:Sapphire) can act as Kerr-media
- Kerr's effect is much faster than saturating absorber allowing one generate very short pulses (~5 fs).

Group Velocity Dispersion (GVD)

Optical pulse in a transparent medium stretches because of GVD



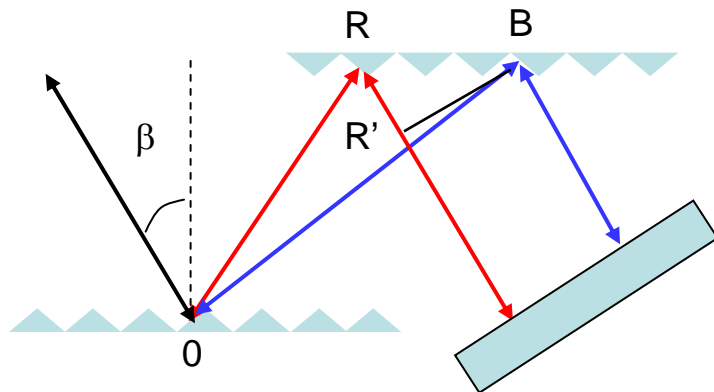
- $v = c / n$ – speed of light in a medium
- n – depends on wavelength, $dn/d\lambda < 0$ – normal dispersion

- Because of GVD, red components (longer wavelengths) of the pulse propagate faster than blue components (shorter wavelengths) leading to pulse stretching (aka “chirp”).
- Uncompensated GVD makes fs laser operation impossible
- GVD can be compensated by material with *abnormal* dispersion

GVD Compensation

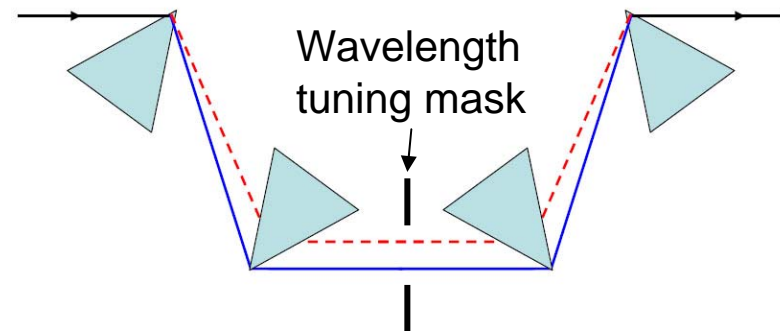
GVD can be compensated if optical pathlength is different for “blue” and “red” components of the pulse.

Diffraction grating compensator



If $OR + RR' > OB$, $GVD < 0$

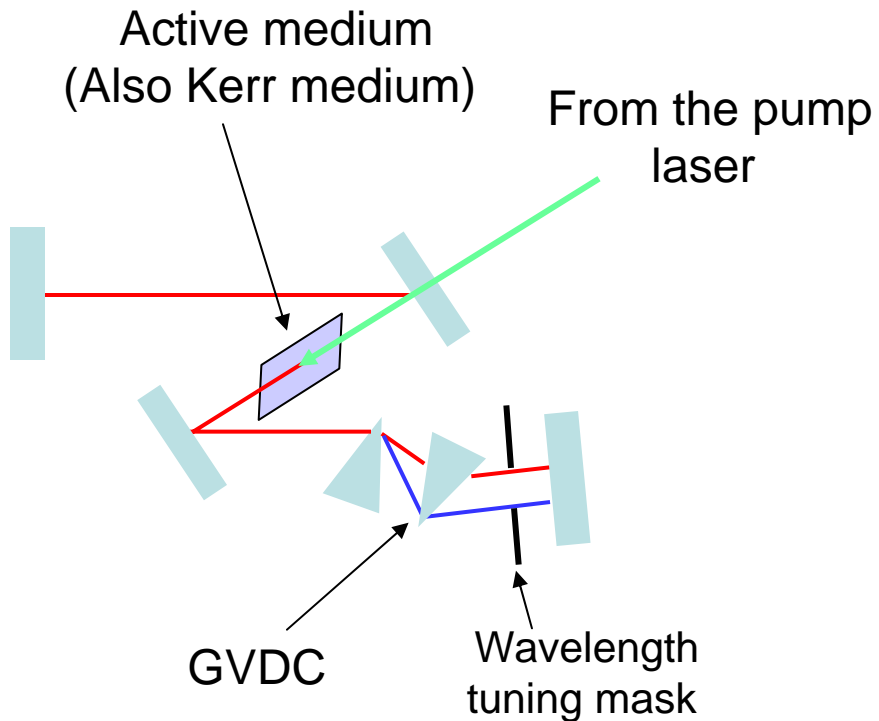
Prism compensator



“Red” component of the pulse propagates in glass more than the “blue” one and has longer optical path ($n \times L$).

Typical fs Oscillator

Typical Ti:Sapphire fs Oscillator Layout



- Tuning range 690-1050 nm
- Pulse duration > 5 fs (typically 50 -100 fs)
- Pulse energy < 10 nJ
- Repetition rate 40 – 1000 MHz (determined by the cavity length)
- Pump source:
 - Ar-ion laser (488+514 nm)
 - DPSS CW YAG laser (532 nm)
- Typical applications:
 - time-resolved emission studies,
 - multi-photon absorption spectroscopy and imaging

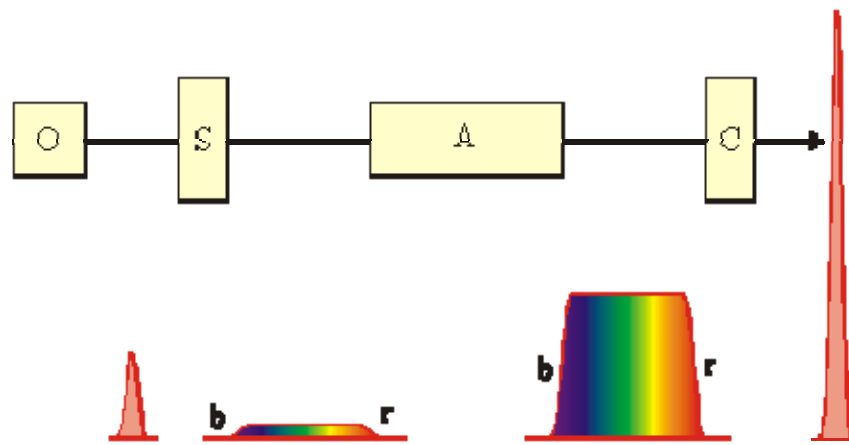
Amplification of fs Pulses

Due to high intensity, fs pulses can not be amplified as is.

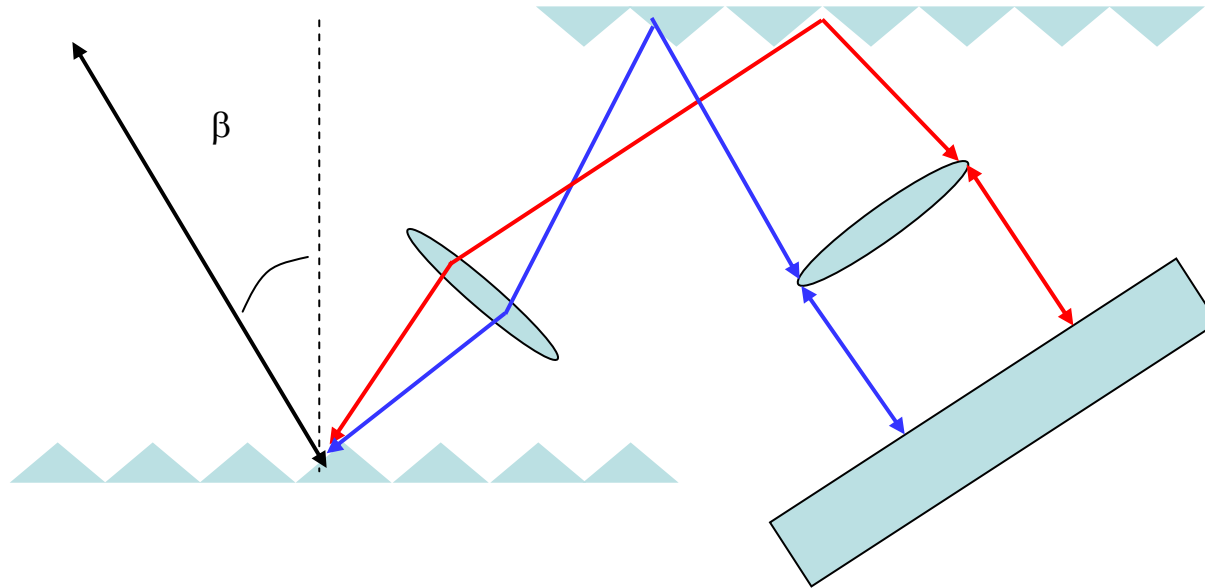
Recipe for the amplification:

Chirped pulse amplifier (CPA)

- Stretch the pulse in time, thus reducing the peak power ($I = J / t_{\text{pulse}} !$) (typically the pulse is stretched up to hundreds of ps)
- Amplify the stretched pulse
- Compress the pulse



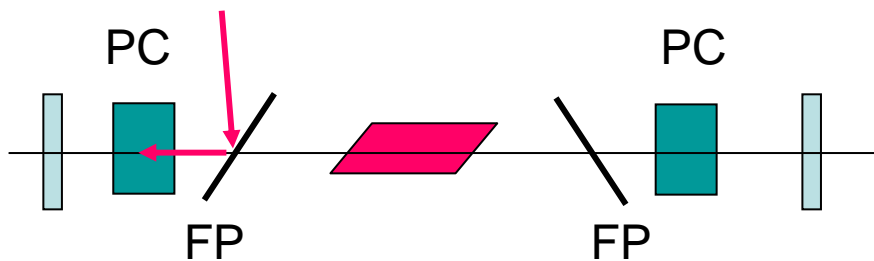
Pulse Stretcher



- Pulse stretcher utilizes the same principle as compressor: separation of spectral components and manipulation with their delays
- Compressor can be converted into stretcher by addition of focusing optics "flipping" paths of red and blue components.

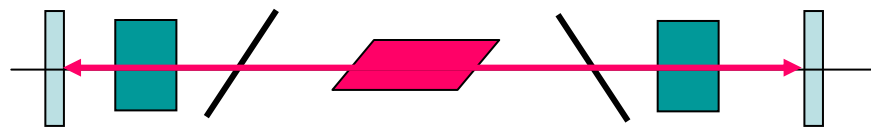
Regenerative Amplifier

Cavity dumping

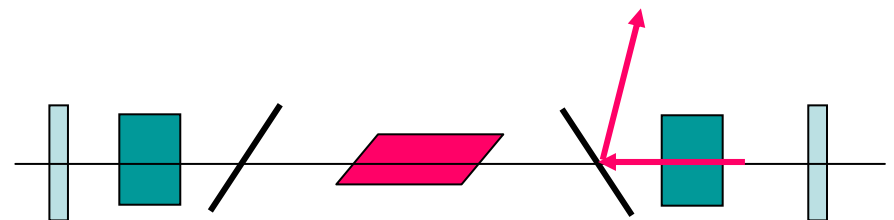


Injection of the pulse from stretcher
(FP – film polarizer, PC – Pockels cell),
Pockels cell rotates polarization of the
seeding pulse

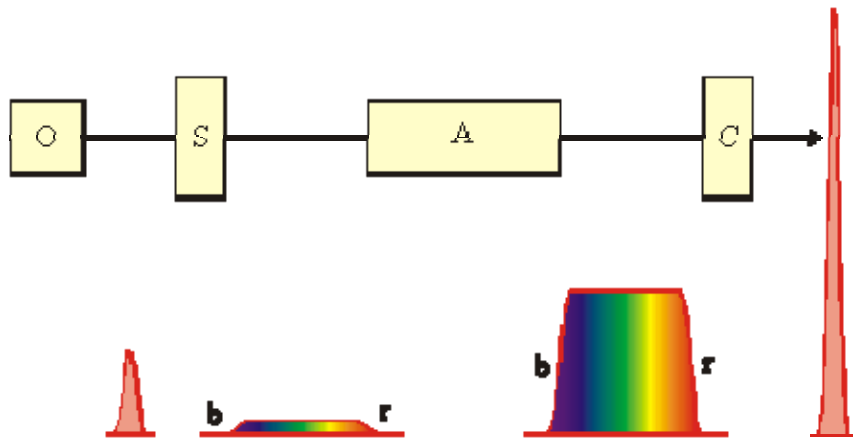
Amplification



Ejection of the pulse into compressor



Typical CPA

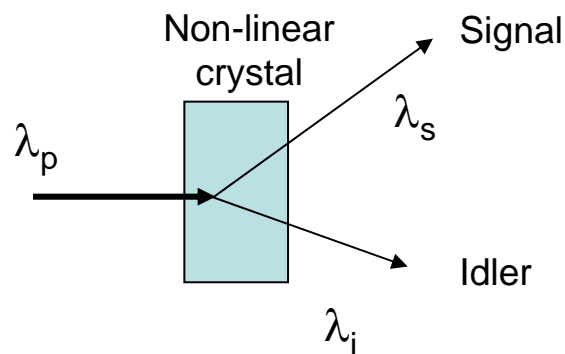


- Repetition rate ~ 1 KHz
- Pulse duration 50-150 fs
- Pulse energy 1 mJ
- Wavelength – usually fixed close to 800nm
- Typical applications:
pumping optical frequency converters,
non-linear spectroscopy, materials
processing

Frequency Conversion of fs Pulses

With fs pulses non-linear optical processes are very efficient due to high intensity of input light: $I_{out} = A I_{in}^m$

Parametric down-conversion



$$\frac{1}{\lambda_p} = \frac{1}{\lambda_s} + \frac{1}{\lambda_i}$$
$$\mathbf{k}_p = \mathbf{k}_s + \mathbf{k}_i$$

Pump : 800 nm, 1mJ, 100 fs
Signal: 1100 -1600 nm, 0.12 mJ
Idler: 1600 – 3000 nm, 0.08 mJ

Optical harmonic generation

Second harmonic

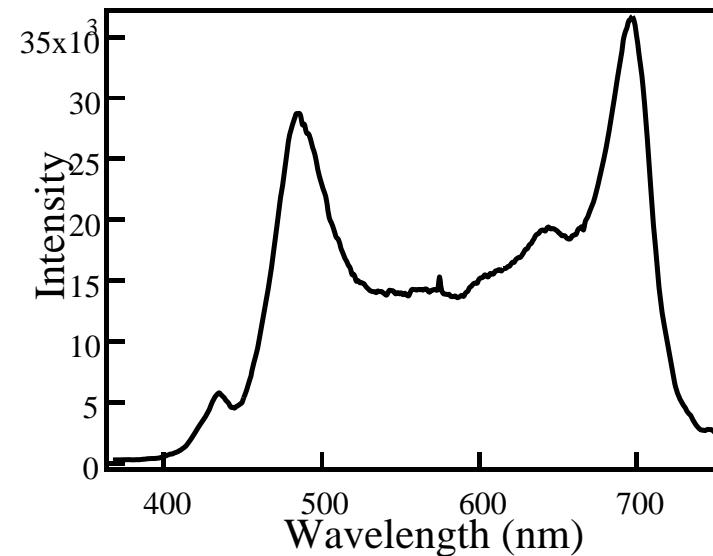
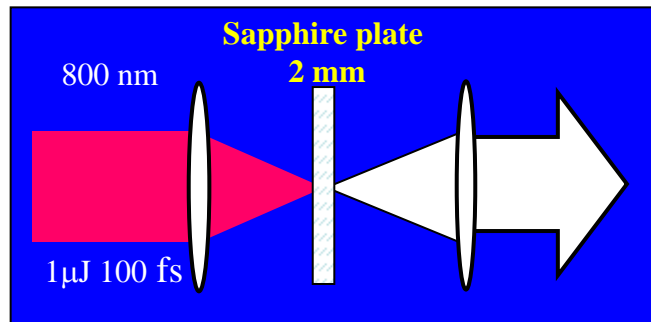
$$\frac{1}{\lambda_{SH}} = 2/\lambda_F$$
$$\mathbf{k}_{SH} = 2 \mathbf{k}_F$$

Pump : 800 nm, 1mJ, 100 fs
SHG: 400 nm, 0.2 mJ

Harmonic generation can be used to upconvert signal or idler into the visible range of spectrum

Femtosecond Continuum

White-light continuum generation



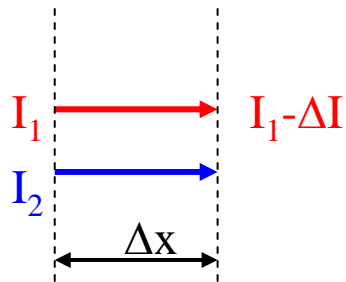
- Self-focusing and self-phase-modulation broadens the spectrum
- Extremely broad-band, ultrafast pulses (Vis and IR ranges)
- Strongly chirped

1.R. L. Fork et al, 8 *Opt.Lett.*, p. 1, (1983)

OCF Femtosecond Equipment

1. Fs oscillator (SP “Tsunami”)
 - 700-980 nm, $t_{\text{pulse}} > 75$ fs, < 10 nJ, 80 MHz repetition rate
2. Regenerative amplifier (SP “Spitfire”)
 - 800 nm, $t_{\text{pulse}} > 110$ fs, 1 mJ, 1 kHz repetition rate
 - Seeded by “Tsunami”
3. Optical parametric amplifier (SP OPA-800C)
 - 1100 – 3000 nm, < 0.15 mJ, $t_{\text{pulse}} > 130$ fs
 - Pumped by “Spitfire”
4. Harmonic generation devices provide ultrashort pulses tunable in the range 400 – 1500 nm
 - Pulse energy < 50 μ J

Two-Photon Absorption



$$\Delta I = -\gamma I_1 I_2 \Delta x$$

$$\gamma = \beta c$$

$$\Delta I = -\gamma I^2 \Delta x$$

Degenerate case

β – TPA cross-section, c – concentration of material

1PA

$$\frac{dI}{dx} = -\sigma c I$$

Beer's Law

$$I(x) = I_0 \exp(-\sigma c x)$$

$$T = \exp(-\sigma c x)$$

TPA

$$\frac{dI}{dx} = -\beta c I^2 = -(\beta c I) I$$

$$I(x) = \frac{I_0}{1 + \beta c I_0 x}$$

$$T = \frac{1}{1 + \beta c x I_0}$$

TPA Cross-Section Units

$$[\beta c I_0 x] = 1 \quad \rightarrow \quad [\beta] = \left[\frac{1}{c I_0 x} \right] = \text{cm}^3 \cdot \frac{\text{s} \cdot \text{cm}^2}{\text{phot}} \cdot \frac{1}{\text{cm}} = \frac{\text{cm}^4 \cdot \text{s}}{\text{phot}}$$

Is not it a bit complicated?

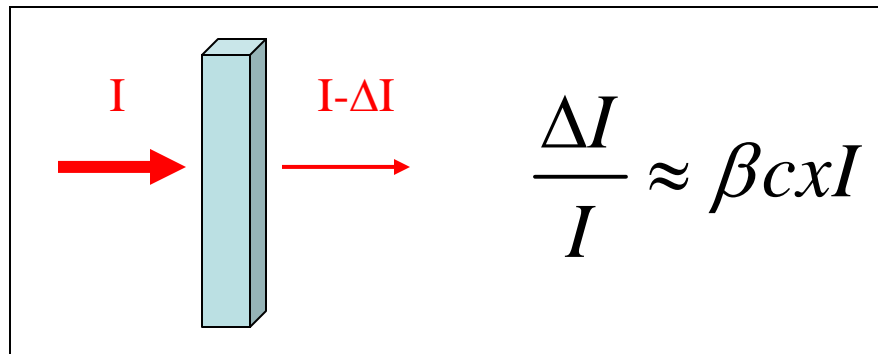
$$10^{-50} \text{cm}^4 \cdot \text{s} / \text{phot} = 1 \text{ GM}$$

Typical TPA absorption cross-section is 1 - 10 GM

Göppert-Mayer M., *Ann.Physik* **9**, 273 (1931)

Do We Really Need a Fs Pulse?

$$\Delta I / I \geq 10^{-5} \quad \text{Accuracy limit of the most of intensity measurements}$$



$$\beta = 10 \text{ GM} \quad c = 10^{-4} \text{ M}$$
$$x = 1 \text{ mm} \quad 1 \text{ W} \sim 10^{18} \text{ phot/sec}$$

$$\mathbf{I = 16 \text{ GW/cm}^2}$$

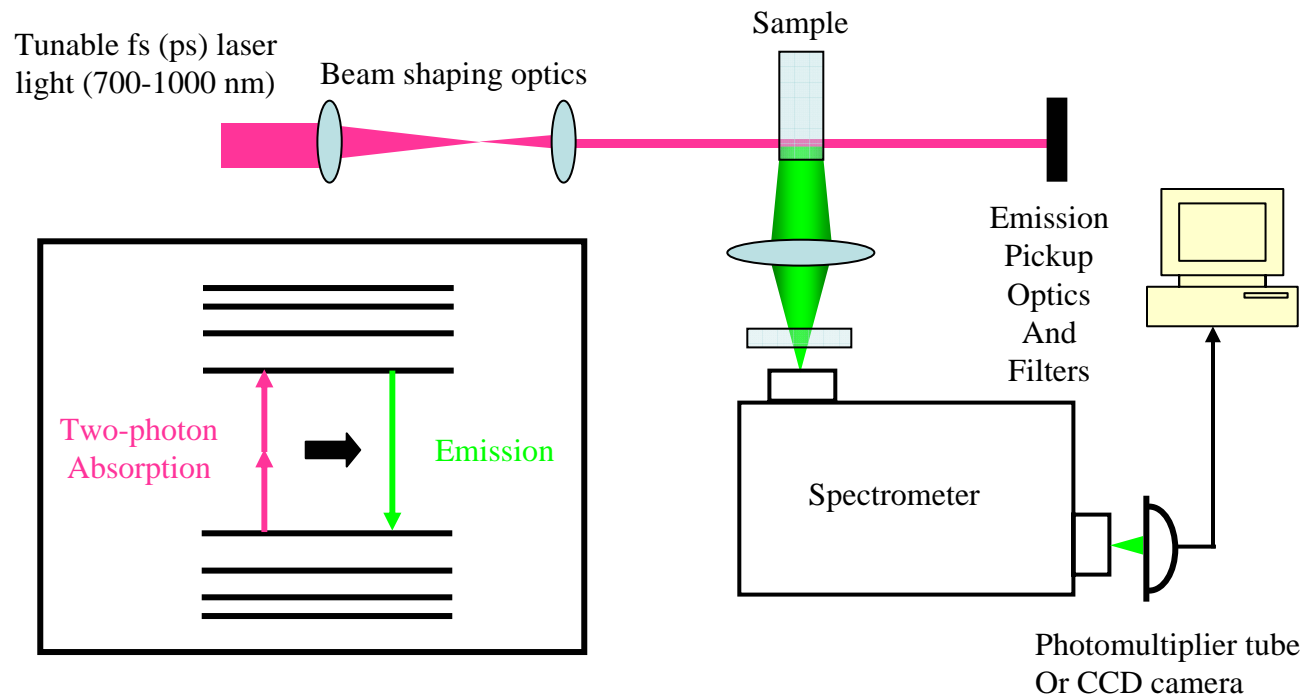
If beam diameter is 10μ , required lasers power/pulse energy is:

CW laser power **12000W**

YAG:Nd laser (10 ns pulse, 25 Hz rep. rate) **120 μ J** pulse energy (**3 mW**)

Ti:Sapphire laser (100 fs pulse, 100 MHz rep. rate), **1.2 nJ** pulse energy (**120 mW**)

TPA PL excitation



Pros:

- Very sensitive
- Easy to setup
- Works without amplifier

Cons:

- Works only for PL emitting materials
- Not absolute (requires reference material)

TPA PLE II

$$I_{PL} = A \cdot \frac{\beta c x I^2}{1 + \beta c x I} \cdot \eta_{PL} \quad , \quad \text{if } \beta c x I \ll 1 \quad , \quad \text{then } I_{PL} \approx A \beta c x I^2 \eta_{PL}$$

β – TPA cross-section, c – concentration, x – length of interaction, I – laser light intensity, A – geometrical factor (**usually unknown**)

TPA PL technique requires a reference measurement

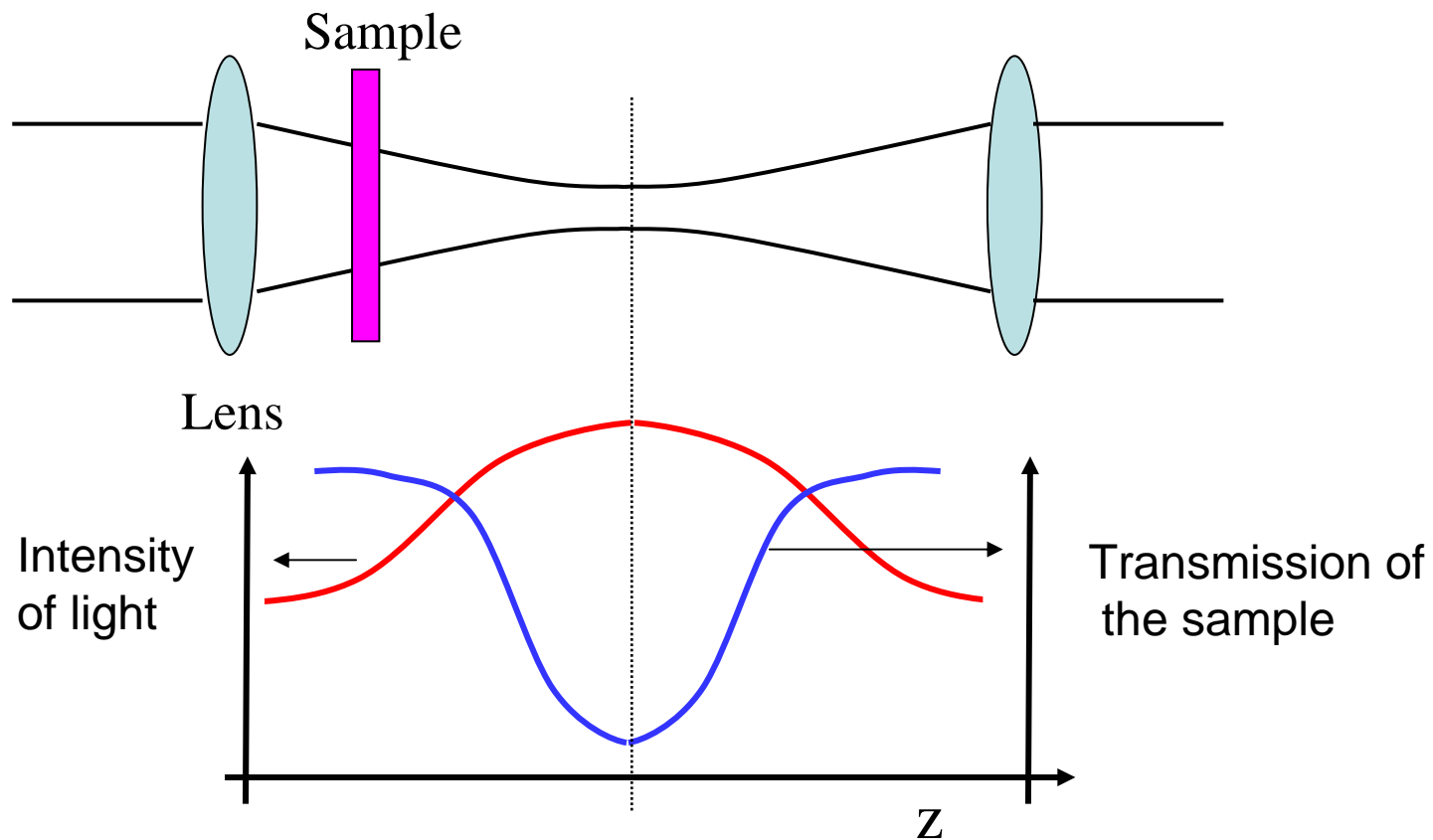
$$\beta = \beta_{ref} \frac{c_{ref} \eta_{PL}^{ref}}{c \eta_{PL}} \cdot \frac{I^2}{I_{ref}^2} B \quad B = \frac{n^2}{n_{ref}^2} \quad \text{for collimated beams}$$

Good reference materials: laser dyes (Fluorescein, Rhodamin, Coumarin)

C. Xu and W. W. Webb, *J. of Am. Opt. Soc.* **13**, 481 (1996)

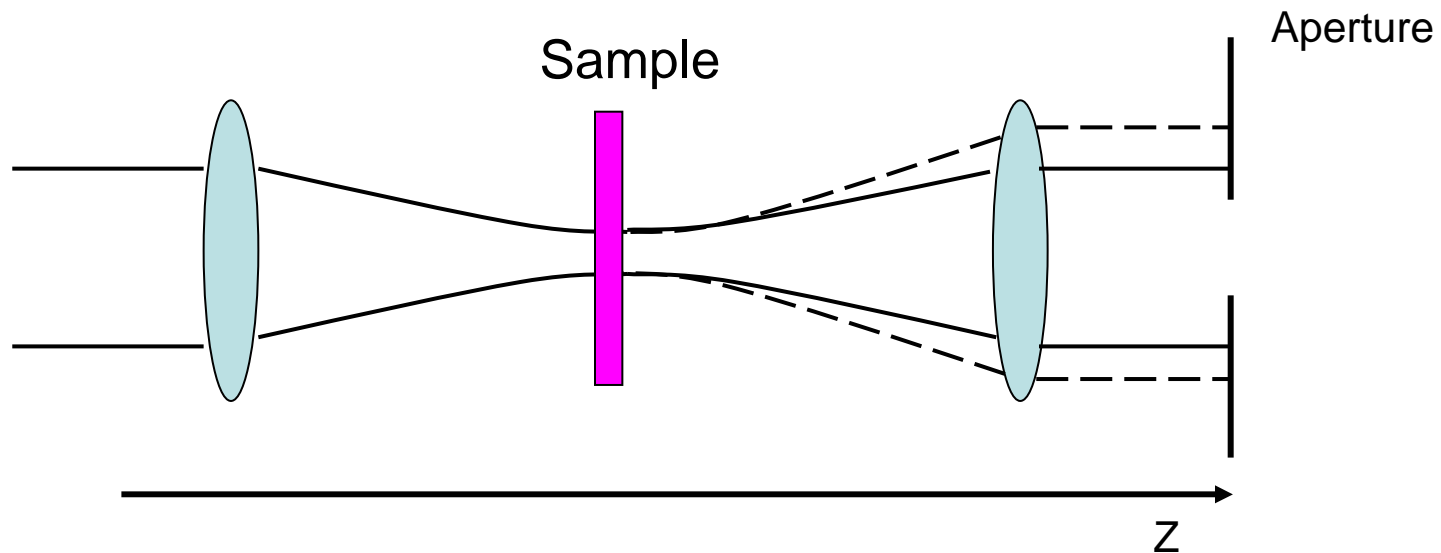
TPA Measurements in Non-Fluorescent Materials

Z-Scan Technique



Open aperture Z-scan, TPA measurements

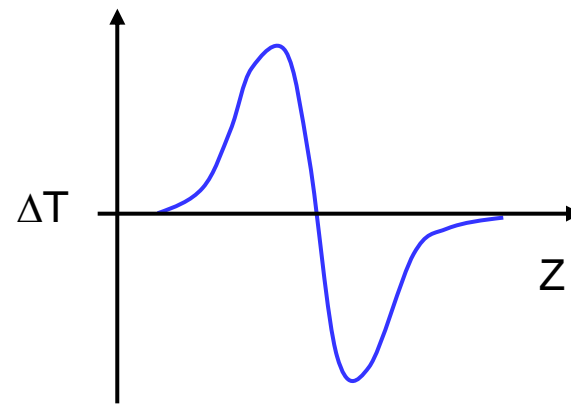
Z-Scan Measurements of Kerr's Non-Linearity



Closed aperture Z-scan

$$n = n_0 + n_2 I$$

- Kerr lens focuses or defocuses light clipped by the aperture thus modulating its transmission



Summary on Z-scan

Cons:

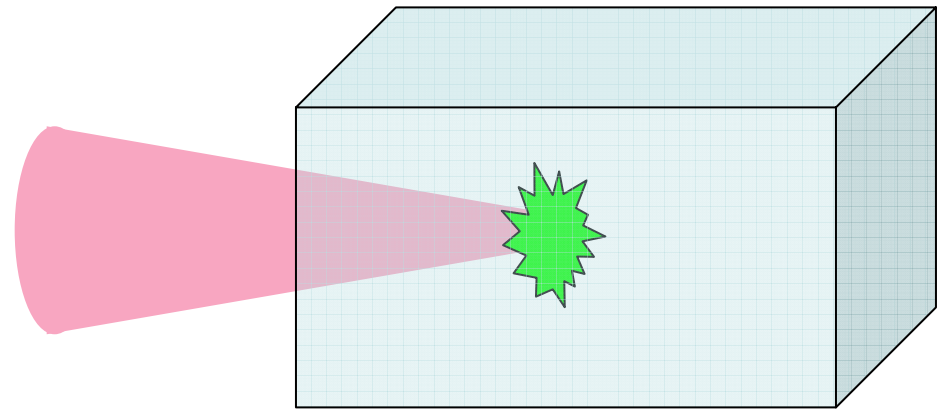
- Z-scan works if the thickness of the sample is much smaller than the beam's waist length.
- Data processing apparatus relies on the Gaussian profile of the beam. Very accurate characterization of the pump beam is required.
- Requires high energy pump pulses as well as high concentration of TPA absorber in order to achieve reasonable accuracy of the data.
- Artifacts are possible due to long-living excited state absorption.

Pros:

- Works with non-fluorescent materials
- Allows one to measure real part of high-order susceptibilities

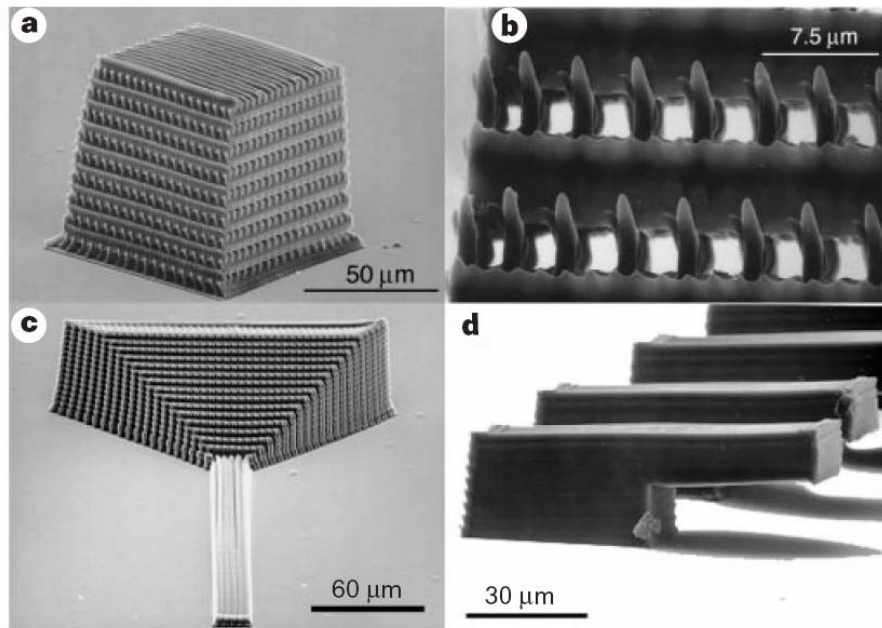
M. Sheik-Bahae *et al*, *IEEE J. of Quantum Electronics*, **26**(4), p. 760 (1990)

TPA Applications



- 3D optical memory
- 3D holographic gratings and photonic structures
- Remote sensing and hi-res imaging

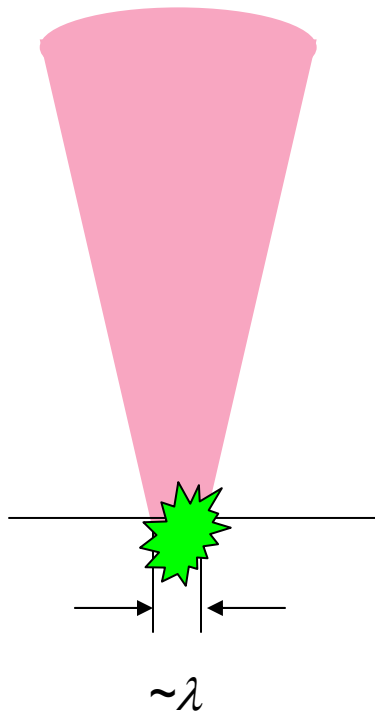
TPA Microfabrication



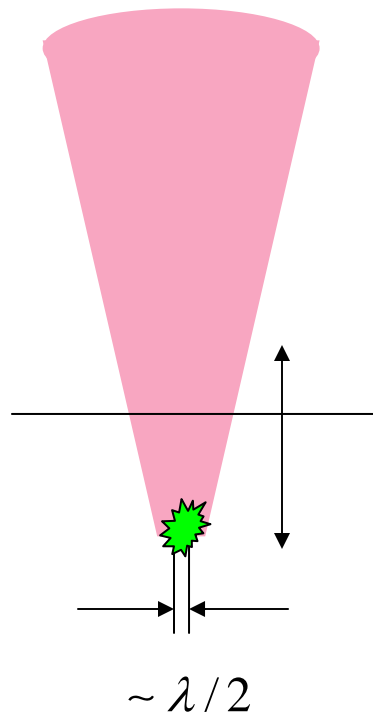
- a. Photonic crystal
- b. Magnified view of (a)
- c. Tapered waveguide
- d. Array of cantilevers

B.H. Cumpston et al., Nature **398**, p. 51 (1999)

TPA Imaging



Single photon
imaging



Two photon
imaging
(works even under
the surface!)

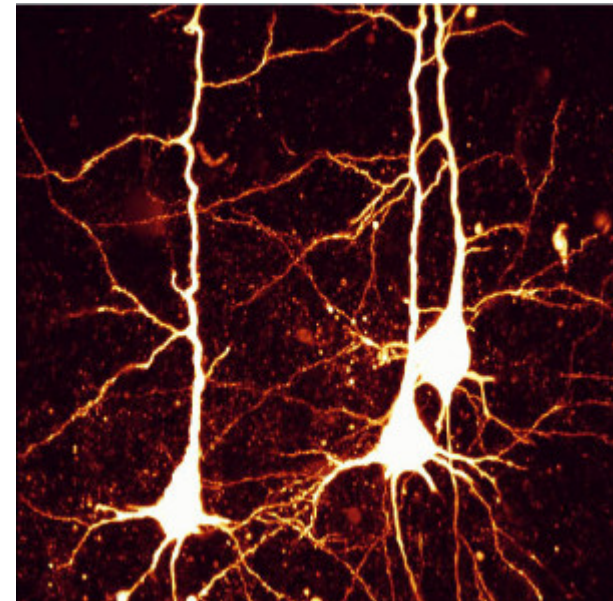
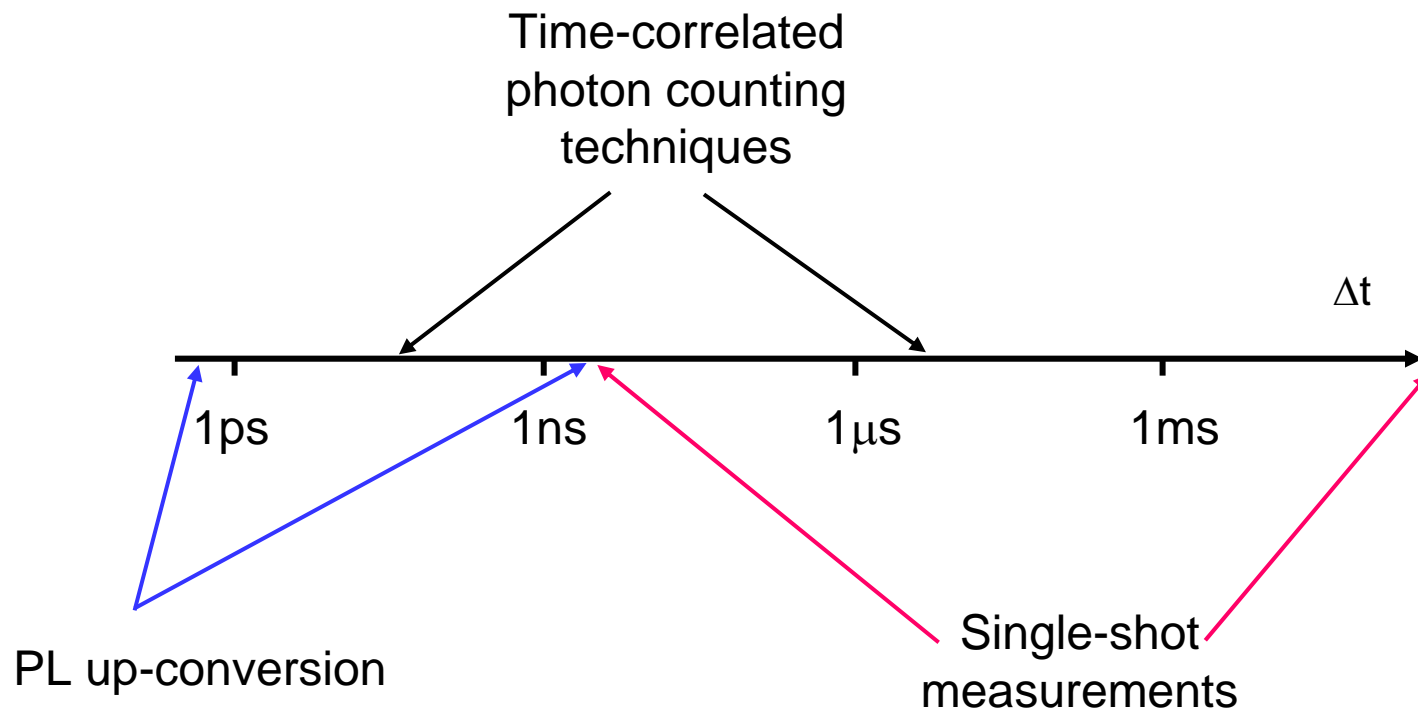
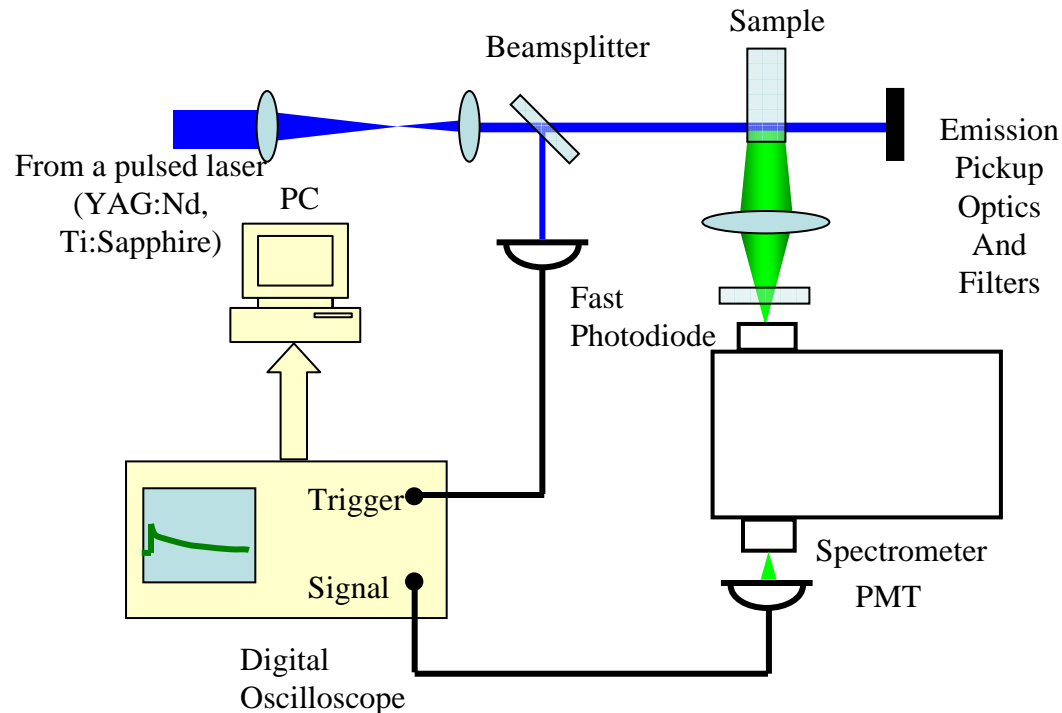


Image from Heidelberg University
web-site

Time-Resolved Emission Spectroscopy



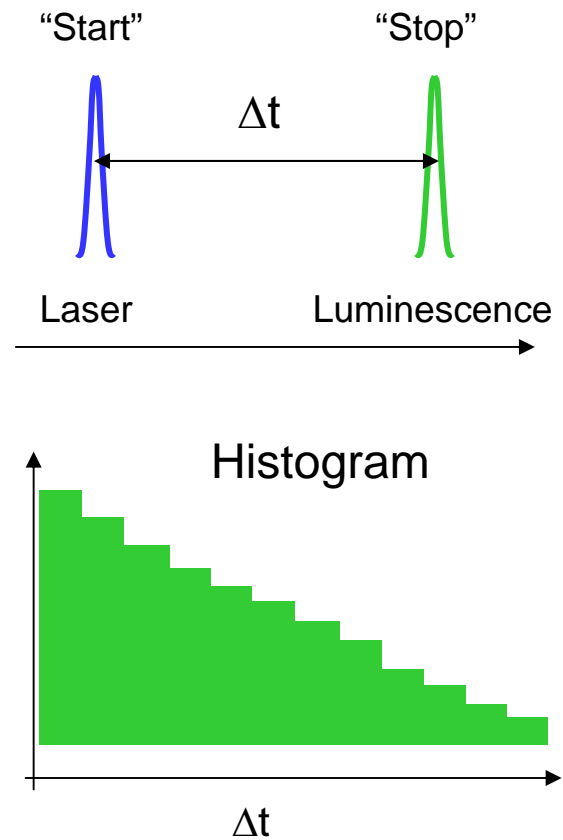
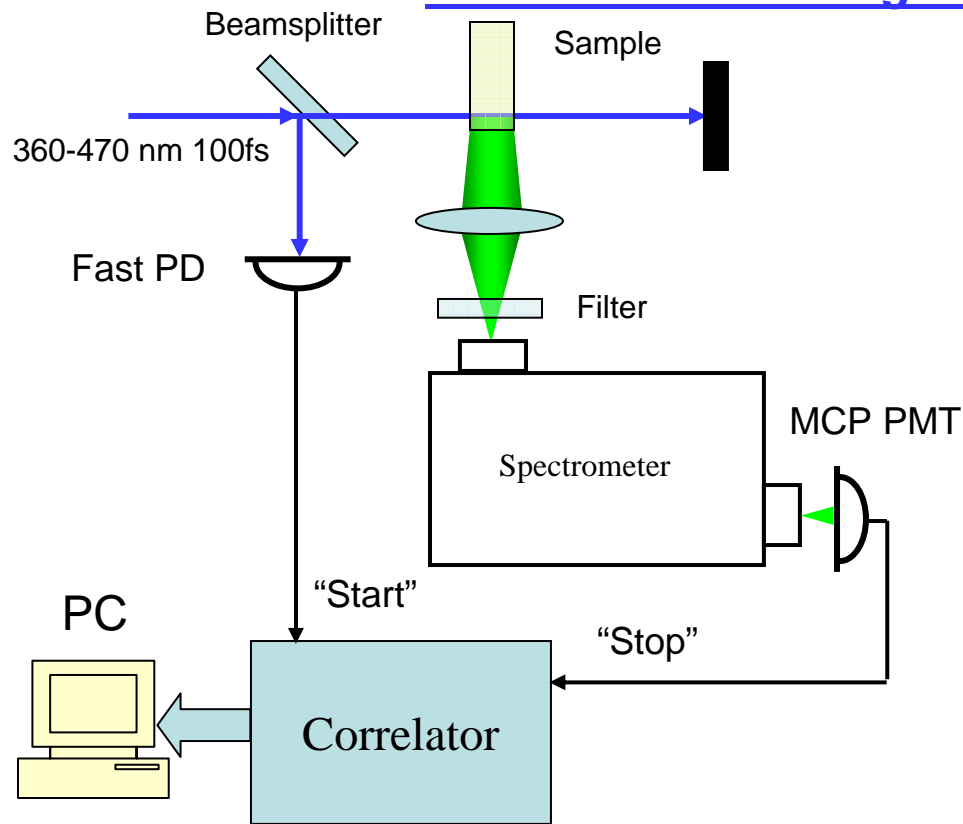
Single-Shot PL Decay Measurement



- Temporal resolution is limited by the detector (~20 ns)
- Works best on amplified laser systems.
- Can collect the data in 1 shot of the laser. (In macroscopic systems)

Time-Resolved Luminescence Experiments

Time-Correlated Single Photon Counting (TCSPC)

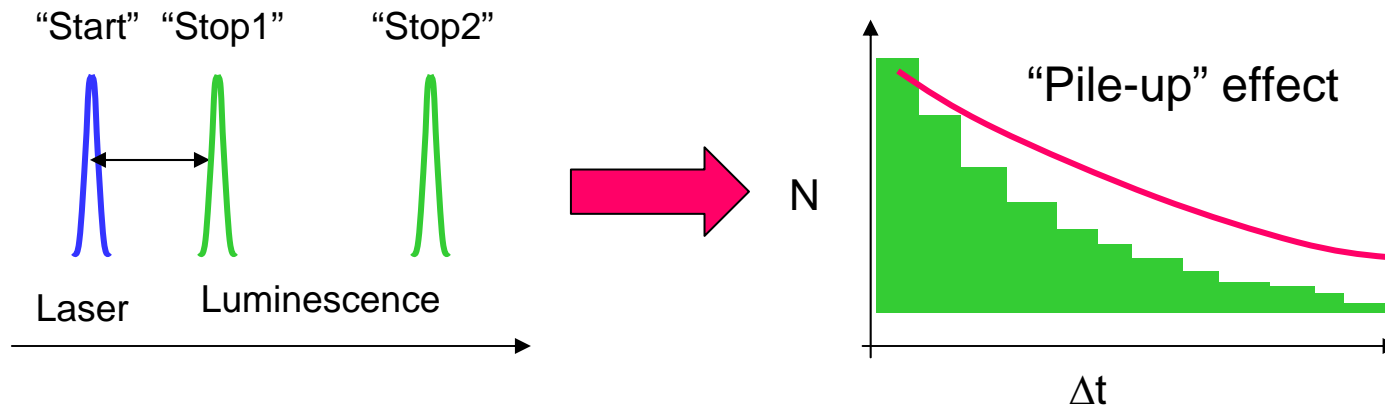


Erdman R., "Time Correlated Single Photon Counting & Fluorescence Spectroscopy", Wiley-VCH, (2005)

TCSPC

- Temporal resolution ~ 50 ps.
- Excitation range 470 – 360 nm, emission range 300 – 900 nm
- Works excellent on timescale < 50 ns, on longer time-scales, data collection time may be quite long.
- Very sensitive, works well with low emission yield materials
- Resolution is limited by the jitter and width of detector response (The highest resolution is possible only with MCP PMT. Price tag \$15K. Regular PMTs provide resolution about 1 ns.)

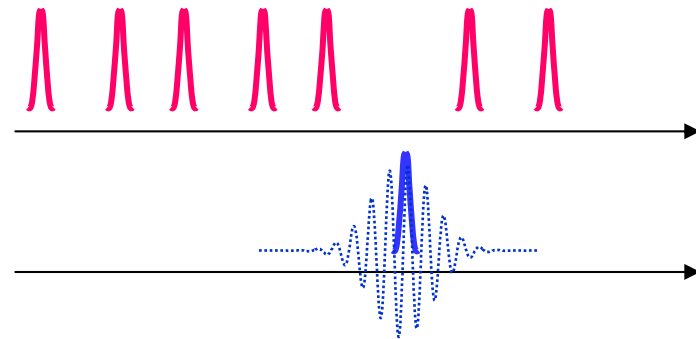
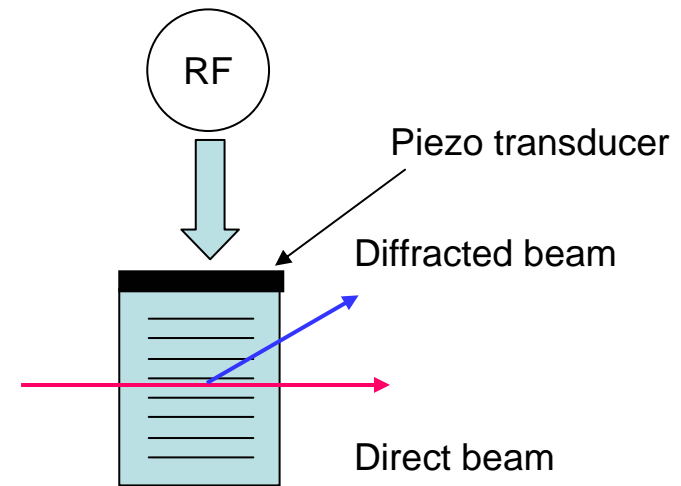
Why *Single Photon* counting?



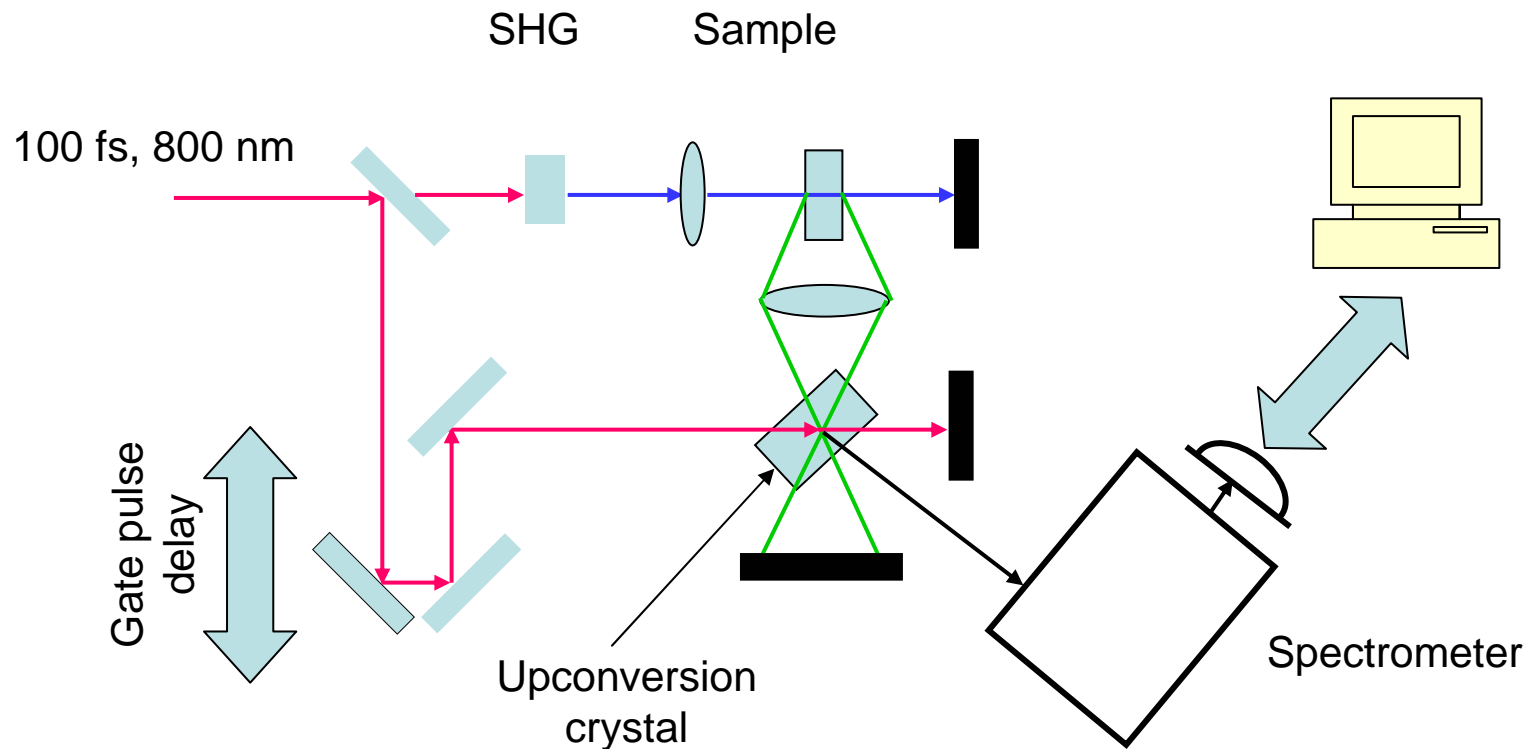
TCSPC II

Acousto-optical pulse picker

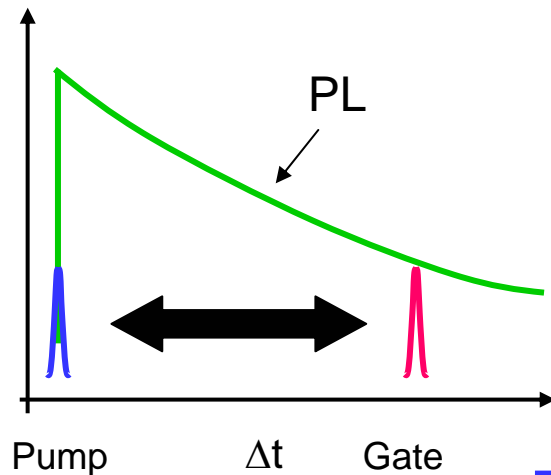
- If the time between laser pulses is shorter or comparable with radiative life-time of the sample, the chromophore can be saturated
- Repetition rate (time between pulses) can be reduced (increased) by using a pulse picker.
- Acousto-optical pulse picker uses controlled diffraction of laser pulses on a grating generated by ultrasound



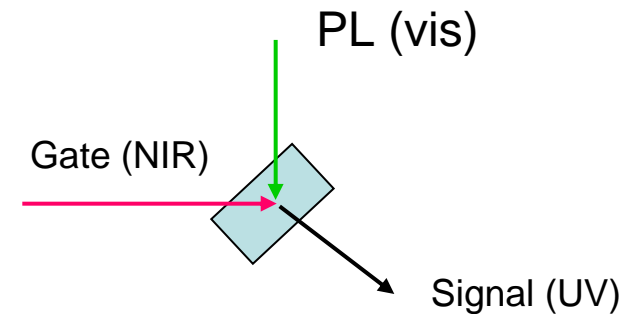
Luminescence Upconversion



Luminescence Upconversion II



Upconversion process = gating

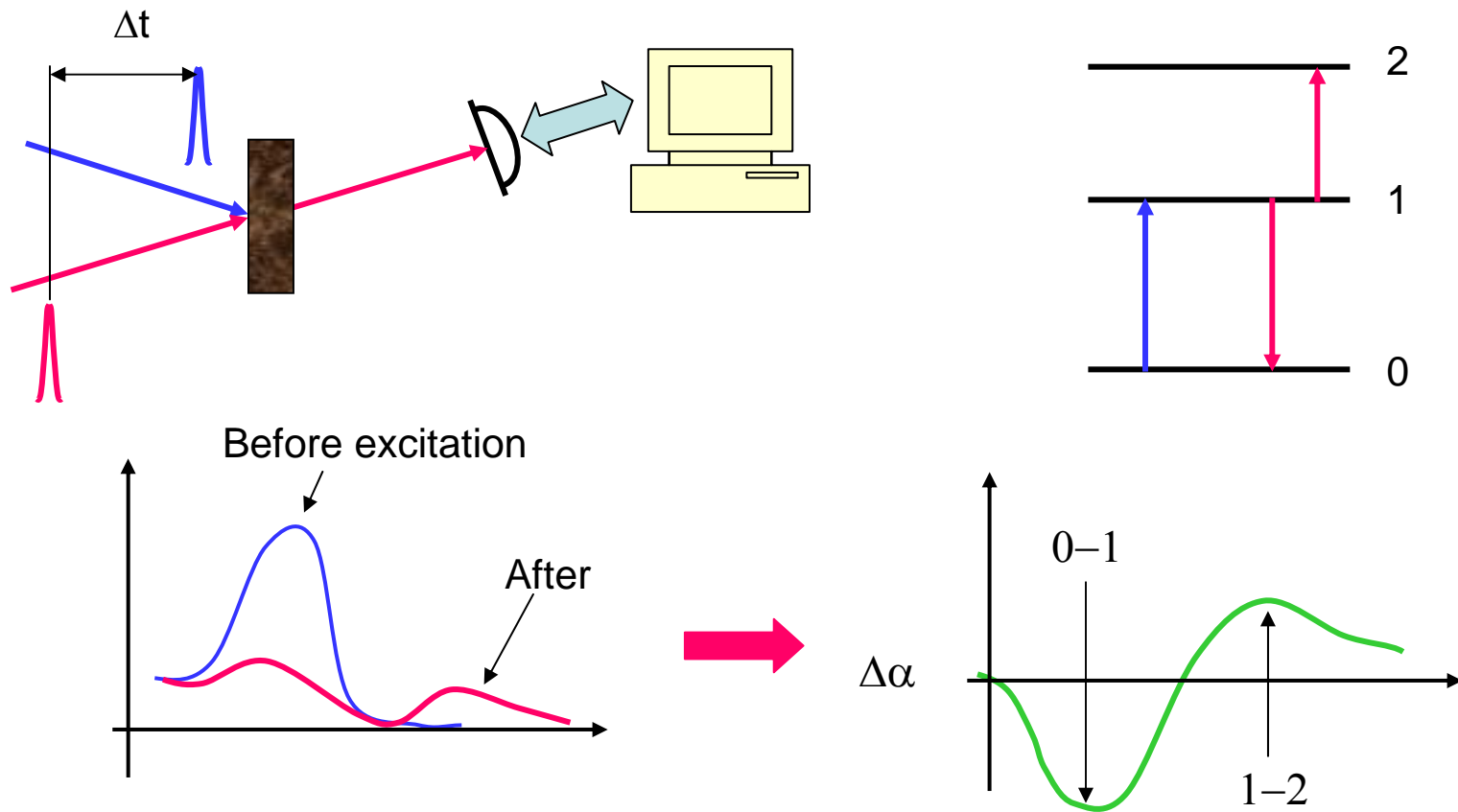


$$\begin{aligned} 1/\lambda_s &= 1/\lambda_{PL} + 1/\lambda_G \\ k_s &= k_{PL} + k_G \\ I_s &\sim I_G I_{PL}(\Delta t) \end{aligned}$$

- Intensity of the signal is proportional to intensity of PL at the moment of the gating pulse arrival.
- Resolution is determined by the gating pulse duration
- High repetition rate and power lasers are required
- Works well with photostable materials
- Limited delay range (mechanical delay 15 cm = 1 ns)

Pump-Probe Experiments I

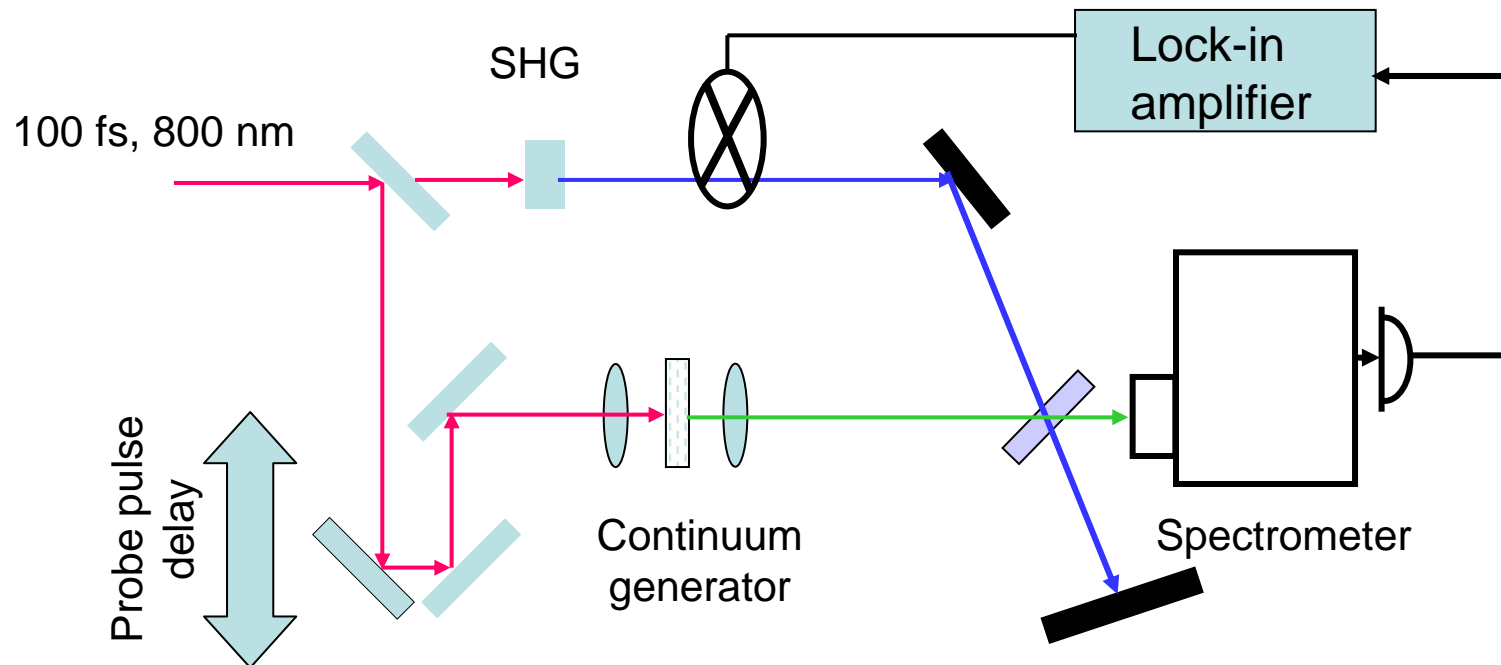
Idea of the experiment



Pump-Probe Experiments II

- PPE enable one to trace the relaxation dynamics with sub-100 fs resolution
- Types of the data generated by PPE: time-resolved absorption spectra and absorption transients at a certain wavelength.
- Numerous combinations of pump and probe beams are possible (UV pump + visible probe, UV-pump+continuum probe, etc.)
- High pump intensities are required in order to produce noticeable change in the optical absorption of the sample (GW/cm^2 – TW/cm^2) (Ti:Sapphire amplifiers are generally required)
- Interpretation of the data is sometimes complicated

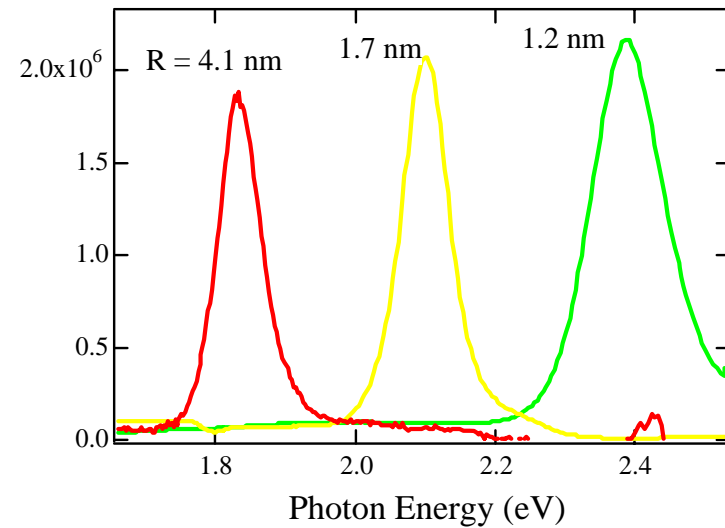
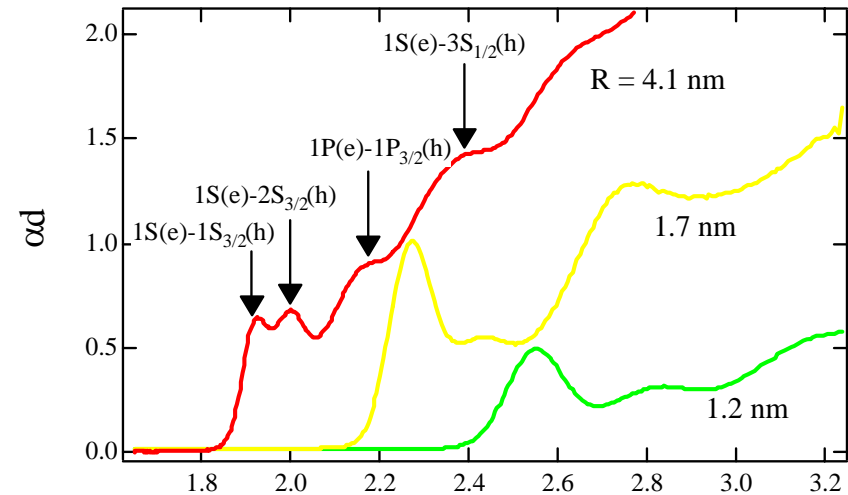
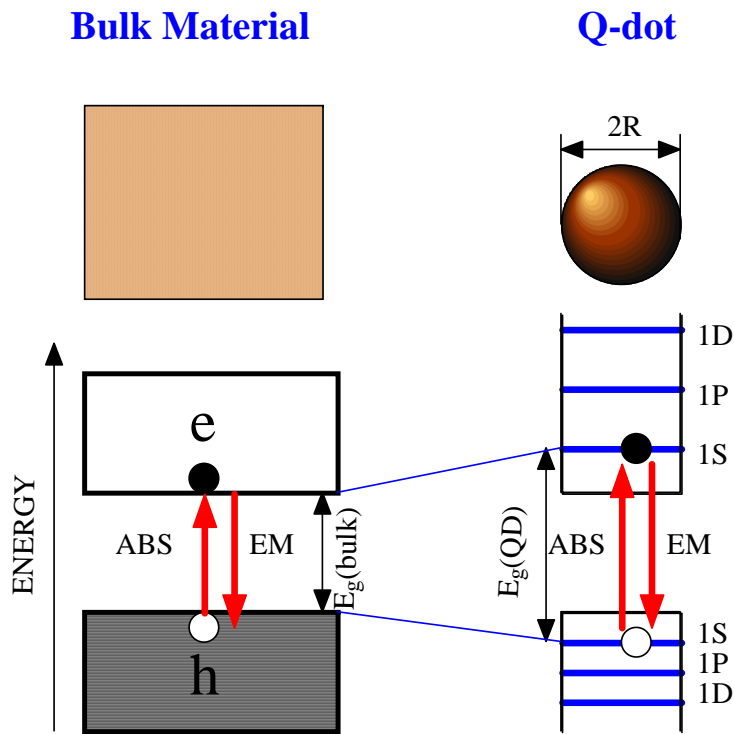
Pump-Probe Experiments III



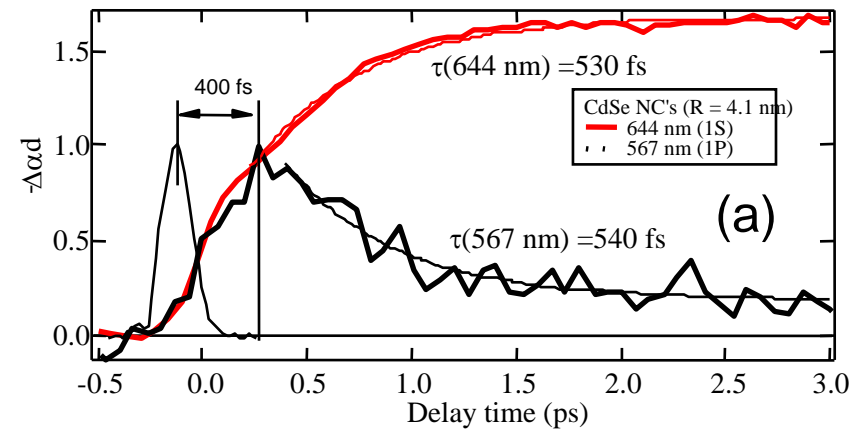
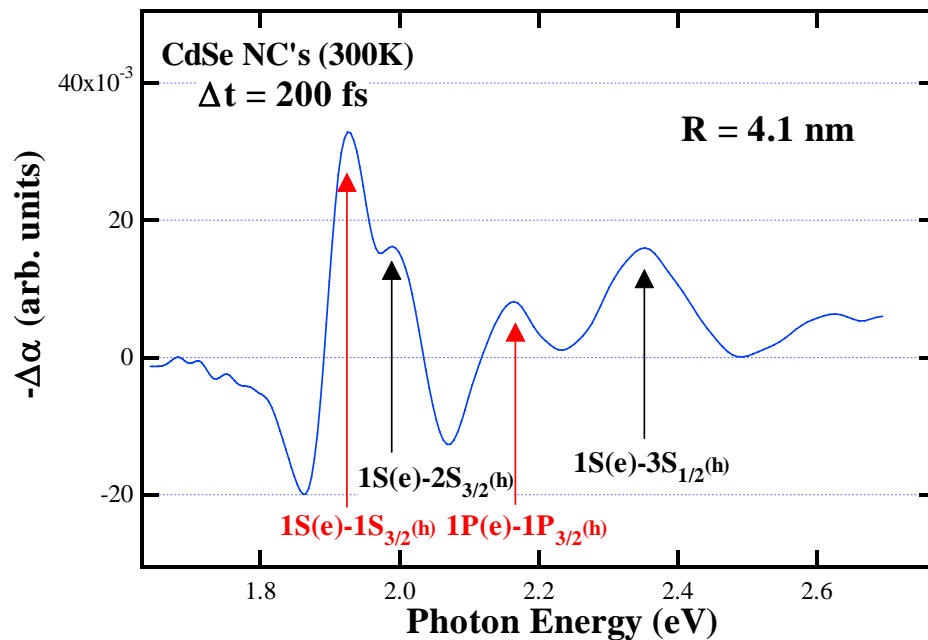
- Detects 10^{-5} transmission change
- PPE spectra can be chirp-corrected during the experiment
- Use of continuum as a probe enables one to cover the entire visible and NIR ranges

V.I. Klimov and D.W. McBranch, Opt.Lett. **23**, p. 277, 1998

Semiconductor Quantum Dots



Transient Absorption Spectroscopy of CdSe Quantum Dots



Klimov V.I. and McBranch D. W., Phys.Rev.Lett. **80**, p. 4028, 1998